



AF

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **KIRA, et al.**

Group Art Unit: 2822

Serial No.: 08/897,953

Examiner: **David E. GRAYBILL**

Filed: July 24, 1997

P.T.O. Confirmation No.: 5157

*Entered by
RCE filed
10/3/06*

For: **METHOD AND SYSTEM FOR FABRICATING A SEMICONDUCTOR DEVICE**

AMENDMENT UNDER 37 CFR §1.116

- EXPEDITED RESPONSE -

GROUP ART UNIT 2822

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 12, 2006

Sir:

In response to the Final Office Action dated **June 14, 2006**, please amend the above-identified application as follows: